



CS00-153

Application no. 10/679,736

June 7, 2004

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Attn: Art Unit 2813 - Examiner Nguyen, Thanh T

FROM: George O. Saile, Reg. No. 19,572  
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SUBJECT: Serial #: 10/679,736  
File Date: 10/06/2003  
Inventor: Young-Way Teh  
Examiner: Nguyen, Thanh T  
Art Unit: 2813  
Title: A Novel Copper Metal Structure for the Reduction of Intra-Metal Capacitance

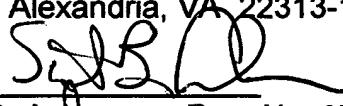
#### RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

This is in response to the Restriction Requirement in the Office Action dated May 5, 2004. In that office action, restriction was required to one of the following Inventions under

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents P.O. Box 1450, Alexandria, VA 22313-1450 on June 7, 2004.

Signature   
Stephen B. Ackerman, Reg. No. 37,761

Date: June 7, 2004

35 U.S.C. 121:

The inventions stated are:

I - Claims 1-18, 24-31, drawn to a method of etching the opening through the dielectric layer, classified in class 438, subclass 637, and

II - Claims 19-23, drawn to multiplayer integrated circuit, classified in class 257, subclass 774.

The restriction requirement was apparently sent in error. Claims 1-18 and 24-31 have already been cancelled upon filing of this Divisional patent application on October 6, 2003.

The Examiner is thus respectfully requested to reconsider the Requirement for Restriction in the Office Action.

Withdrawal of the Restriction Requirement, and allowance of the present Patent Application, is respectfully requested.

It is requested that should there be any problems with this response, please call the undersigned Attorney at (845) 452-5863.

Respectfully submitted,



Stephen B. Ackerman, Reg. No. 37,761